

Docket No. 740819-466

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takumi MIKAWA et al.

Application No. 09/734,176

Filed: December 12, 2000

For: SEMICONDUCTOR DEVICE AND  
METHOD FOR FABRICATING THE  
SAME

)

) Group Art Unit: 2811

) Examiner: Steven Ho Yin Loke

) Confirmation No. 5101

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at (703) 872-9306, on July 26, 2004.

  
Angelique Graham

## AMENDMENT

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed March 29, 2004, please consider the amendments and remarks in connection with the above-identified application as follows.

NVA301550.1